



21ST INTERNATIONAL CONFERENCE

SMMIB2019

SURFACE MODIFICATION OF MATERIALS BY ION BEAMS

Tomsk, 25-30 August 2019

2ND ANNOUNCEMENT



TOMSK
POLYTECHNIC
UNIVERSITY



CHAIRS:

Wolfgang Ensinger

Daryush Ila

Gennady Remnev



IMPORTANT DATES

ABSTRACT SUBMISSION DEADLINE **APRIL 30, 2019**

ABSTRACT ACCEPTANCE NOTIFICATION **MAY 15, 2019**

EARLY BIRD REGISTRATION COMPLETED BY **MAY 31, 2019**



More information **SMMIB.RU**



On behalf of the Organizing Committee, it is my great pleasure to invite you for the next International Conference on Surface Modification of Materials by Ion Beams (SMMIB-2019), which will be held in Tomsk, Russia, on August 25-30, 2019.

The conference gathers scientists from all over the world to exchange ideas, share new knowledge and future trends of ion beam technologies.

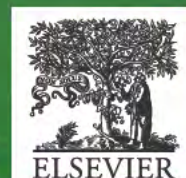
21-st SMMIB includes plenary sessions, keynote lectures and several specialized sessions on different topics related to surface modification by ion beams with relevant applications in advanced materials, nanotechnology, nuclear materials, information and communication technologies, medical and industrial applications.

All details and updates will be posted on the website, so please bookmark it for your future information.

We hope to see you in Tomsk for what promises to be a memorable and enjoyable meeting.

Co-chair, Gennady E. Remnev

JOURNAL
SURFACE AND COATINGS TECHNOLOGY (Q1)





CHAIRS

Wolfgang Ensinger

Daryush Ila

Gennady Remnev



INTERNATIONAL SCIENTIFIC COMMITTEE

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CONFERENCE TOPICS

Basic mechanisms, theory and fundamentals

Ion-assisted coating deposition

Ion beam processing of materials

Defect engineering, nano-science and technology

Biomedical and industrial applications

New accelerator systems and tools for materials research



ABOUT US



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